

Attorney Docket No. 06089/LH

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Keiichi TANAKA

Serial No. : 10/569,167

Confirm. No.: 1699

Filed : October 24, 2006

For : VACUUM DEVICE, OPERATION METHOD
FOR VACUUM DEVICE, EXPOSURE
SYSTEM, AND OPERATION METHOD FOR
EXPOSURE SYSTEM

Art Unit : 2882

Examiner : STEVEN H. WHITESELL GORDON

RESPONSE- 37 C.F.R. 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R :

This is responsive to the Office Action mailed
January 15, 2010, the term for response to which expires on
February 15, 2010.

ELECTION

Applicants hereby elect the species of Group 1, for further
prosecution on the merits, without traverse.

This paper is being
submitted via EFS-Web on
February 8, 2010

In the event that this
Paper is late filed, and
the necessary petition for
extension of time is not
filed concurrently
herewith, please consider
this as a Petition for the
requisite extension of
time, and to the extent not
already paid, authorization
to charge the extension fee
to Account No. 06-1378. In
addition, authorization is
hereby given to charge any
fees for which payment has
not been submitted, or to
credit any overpayments, to
Account No. 06-1378.